



Docket No. 740756-1894

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shunpei YAMAZAKI et al.

Serial No. 09/197,534

Filed: November 23, 1998

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)

) Group Art Unit: 2823

) Examiner: William D. Coleman

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[37 CFR 1.8(a)]

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**PRELIMINARY AMENDMENT**

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please preliminarily amend the subject application as follows:

IN THE CLAIMS:

1. (Currently Amended) A method of manufacturing a semiconductor device comprising the steps of:
  - preparing a plurality of semiconductor islands over a glass substrate;
  - subjecting said semiconductor islands to an ion doping;
  - directing a pulsed laser beam having a cross section elongated in one direction to said glass substrate;

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